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PATENT APPLICATION

Attorney Docket No.: 111673

AMENDMENT TRANSMITTAL

In re the Application of

Takashi AOKI et al.

Group Art Unit: 2851

Application No.: 10/030,822

Examiner: R. Fuller

Filed: January 16, 2002

For: EXPOSURE METHOD AND SYSTEM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ Entitlement to small entity status is hereby asserted.
☐ Small entity status of this application has been established.

The filing fee has been calculated as shown below:

	(Column 1)	(Column 2)	(Column 3)	SMALL ENTITY			OTHER THAN A SMALL ENTITY	
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADD'L FEE	OR	RATE	ADD'L FEE
TOTAL CLAIMS	*35 MINUS	**29	=6	x 9	\$		x 18	\$ 108
INDEP CLAIMS	*10 MINUS	***8	=2	x 43	\$		x 86	\$ 172
<input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+145	\$	OR	+290	\$
					\$			\$ 280

- * If the entry in Column 1 is less than the entry in Column 2, write "0" in Column 3.
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

The "Highest Number Previously Paid For" in this space (Total or Independent) is the highest number found from the equivalent box in Column 1 of a prior Amendment or the number of claims originally filed.

- ☒ Check No. 153987 in the amount of \$280.00 is attached. The Commissioner is hereby authorized to charge any other fees that may be required to complete this filing, or to credit any overpayment, to Deposit Account No. 15-0461. Two duplicate copies of this sheet are attached.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC/ccs

Date: May 12, 2004



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AMENDMENT

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Sir:

In reply to the November 13, 2003, Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.